

Attorney's Docket No.: 4733 USA D01/TCG/TPG/OTHE
Confirmation No.: 9641

Patent



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

Steven Verhaverbeke et al.)

Application No: 10/616,093)

Filed: July 8, 2003)

For: ASSISTED RINSING IN A SINGLE)
WAFER CLEANING PROCESS)

Examiner: Markoff, Alexander

Art Unit: 1746

Mail Stop RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION
ACCOMPANYING A REQUEST FOR CONTINUED EXAMINATION (RCE)

Dear Examiner:

In response to the Final Office Action mailed September 20, 2006, please enter the following amendments and consider the following remarks. A Request Continued Examination (RCE) is filed herewith.

FIRST-CLASS CERTIFICATE OF MAILING

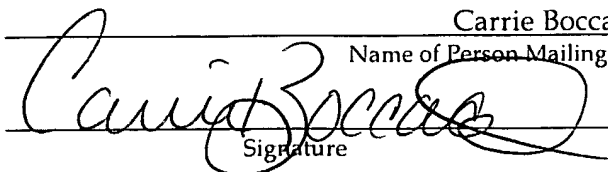
I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on:

January 22, 2007

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1/22/2007

Date

Application No.: 10/616,093
Filing Date: July 8, 2003

AMAT Ref. No.: 4733 USA D01/TCG/TPG/OTHE
- 1/15- BSTZ Ref. No.: 004887.P446D